

3723

## AMENDMENT TRANSMITTAL LETTER (Large Entity)

Applicant(s): Tim Dyer, et al.

OCT 22 2002

Docket No.

35013.4000

Serial No.  
09/836,426Filing Date  
April 17, 2001Examiner  
McDonald, Shantese L.Group Art Unit  
3723

Invention: CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS FOR REMOVING MATERIAL FROM A SURFACE OF A WORKPIECE THAT INCLUDES LOW-K MATERIAL

TO THE ASSISTANT COMMISSIONER FOR PATENTS

Transmitted herewith is an amendment in the above-identified application.

The fee has been calculated and is transmitted as shown below.

## CLAIMS AS AMENDED

	CLAIMS REMAINING AFTER AMENDMENT	HIGHEST # PREV. PAID FOR	NUMBER EXTRA CLAIMS PRESENT	RATE	ADDITIONAL FEE
TOTAL CLAIMS	33 -	33 =	0	x \$18.00	\$0.00
INDEP. CLAIMS	6 -	6 =	0	x \$84.00	\$0.00
Multiple Dependent Claims (check if applicable) <input type="checkbox"/>					\$0.00
TOTAL ADDITIONAL FEE FOR THIS AMENDMENT					\$0.00

No additional fee is required for amendment.

Please charge Deposit Account No. in the amount of  
A duplicate copy of this sheet is enclosed.

A check in the amount of to cover the filing fee is enclosed.

The Commissioner is hereby authorized to charge payment of the following fees associated with this communication or credit any overpayment to Deposit Account No. 19-2814  
A duplicate copy of this sheet is enclosed.

Any additional filing fees required under 37 C.F.R. 1.16.

Any patent application processing fees under 37 CFR 1.17.



Signature

Cynthia L. Pillote, Reg. No. 42,999  
 Snell & Wilmer L.L.P.  
 One Arizona Center  
 400 East Van Buren  
 Phoenix, Arizona 85004-2202  
 (602) 382-6296  
 (602) 382-6070 - Facsimile

Dated: October 17, 2002

I certify that this document and fee is being deposited on October 17, 2002 with the U.S. Postal Service as first class mail under 37 C.F.R. 1.8 and is addressed to the Assistant Commissioner for Patents, Washington, D.C. 20231.


 Signature of Person Mailing Correspondence

Suzie G. Mascari

Typed or Printed Name of Person Mailing Correspondence

CC:



**CERTIFICATE OF MAILING BY FIRST CLASS U.S. MAIL**

I hereby certify that this Response Pursuant to 37 C.F.R. 1.8 is being deposited with the United States Postal Service as first class mail in an envelope addressed to: Commissioner for Patents, Box Non-Fee Amendment, Washington D.C. 20231, on:

Date: October 17, 2002 By Suzie J. Mascari

-- PATENT --

**IN THE UNITED STATES PATENT  
AND TRADEMARK OFFICE**

Applicant(s): Tim Dyer, et al. Attorney Docket No.: 35013.4000  
Serial No.: 09/836,426 Group Art Unit: 3723  
Filed: April 17, 2001 Examiner: McDonald, Shantese L.  
TITLE: CHEMICAL MECHANICAL POLISHING METHOD AND APPARATUS  
FOR REMOVING MATERIAL FROM A SURFACE OF A WORKPIECE  
THAT INCLUDES LOW-K MATERIAL



**RESPONSE AND AMENDMENT**

Commissioner for Patents  
Box Non-Fee Amendment  
Washington, D.C.

Dear Sir:

Applicants hereby timely respond to the Office Action mailed August 1, 2002, within the three-month shortened statutory period to respond. Please amend claims 1, 2, 4, 12, 25, 26, 32, and 33 to read as follows and consider the remarks set forth below.

**IN THE CLAIMS**

1. An apparatus for polishing a surface of a workpiece, the surface including a low dielectric constant material, comprising: